

Notice of References Cited

Application/Control No.

09/512,149

Applicant(s)/Patent Under
Reexamination
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Examiner

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Art Unit

2814

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	B	US-5,760,474	06-1998	Schuele, Paul J.	257/754
	C	US-5,864,496	01-1999	Mueller et al.	365/69
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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